

Atty. Docket No. OG03-042

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

:

Seung Jong YOO

: GROUP ART UNIT:

SERIAL NO: NEW APPLICATION

:

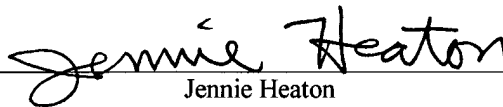
FILED: HERewith

: EXAMINER:

FOR: Method for Fabricating Nonvolatile Memory Device

I hereby certify that this document is being deposited with the United States Postal Service as Express Mail No. EU88162576US in an envelope addressed to Commissioner for Patents, Washington, D.C. 20231, on December 31, 2003.

By:


Jennie Heaton

REQUEST FOR PRIORITY UNDER 35 U.S.C. 119(a)-(b) AND 37 C.F.R. 1.55

COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Applicant respectfully requests under the Paris Convention for the Protection of Intellectual Property the benefit of the filing date of the prior foreign application(s) identified below:

<u>Serial No.</u>	<u>Filing Date</u>	<u>Country of Filing</u>
10-2002-0087897	December 31, 2002	Republic of KOREA

A certified copy of the priority application will be filed before any U.S. patent issues from the above-captioned application.

Respectfully submitted,



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